

Amendments to the Specification:

Please replace the paragraph starting at page 15, line 10 with the following amended paragraph:

-- FIG. 5B is a side elevation plan view of a guide plate and cover for a vacuum electron device enclosure in a closed position in accordance with an alternative specific embodiment of the present invention. A cover 500 is in a closed position and is seated on a VED enclosure (not shown). Shafts 506 and 508 are disposed inside track 502. Shaft ~~412~~ 508 comes into contact with sensor 408. The pressure applied on sensor 408 by shaft ~~412~~ 508 allows power to the high voltage connection. --